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Supporting Information

GaPS₂Se₂ Monolayer: Novel Stable 2D Janus Semiconductor with Anisotropic Properties for Spontaneous Water splitting under the Irradiation of Solar Light

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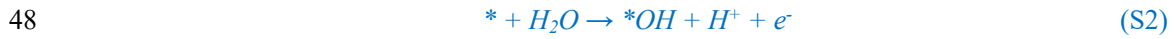
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35 **Note 1:** Photocatalytic water splitting contains two half-reactions, the oxygen evolution reaction
 36 (OER) and hydrogen evolution reaction (HER), where the two half-reactions can be obtained based
 37 on the theory developed by Nørskov et al[1]. That is the adsorption energy difference (ΔG) in the
 38 water redox reaction, which can be calculated as:

$$39 \quad \Delta G = \Delta E_{DFT} + \Delta ZPE - T\Delta S \quad (S1)$$

40 In which ΔE_{DFT} is the adsorption energy obtained from DFT calculation, ΔZPE is the zero-point
 41 energy, T is the temperature at 298.15 K and ΔS is the entropy difference between the adsorption
 42 state and gas phase.

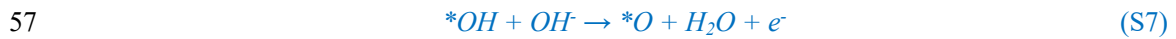
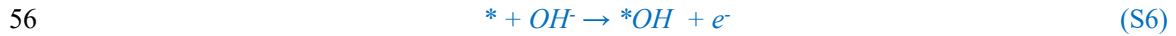
43 The OER process is the half-reaction of the photocatalytic water splitting process, where the reaction
 44 mechanism can be divided into two parts: the acid condition and the alkaline condition. Under acid
 45 medium, the total reaction is $2H_2O \rightarrow O_2 + 4H^+ + 4e^-$, and the reaction is $4OH^- \rightarrow O_2 + H_2O + 4e^-$,
 46 As for the OER process, there are four elementary steps to transfer H_2O to O_2 , which could be
 47 described as following under acid conditions:



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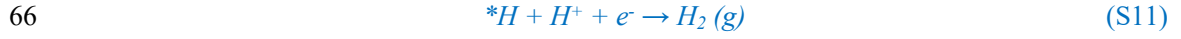
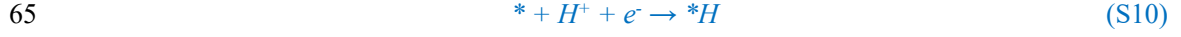
53 Where ‘*’, H^+ , and e^- are the GaPS₂Se₂ substrate, proton, and electron respectively. And *OH, *O,
 54 *OOH are the adsorption intermediate.

55 The corresponding reaction pathway for OER under alkaline condition is described as follow:

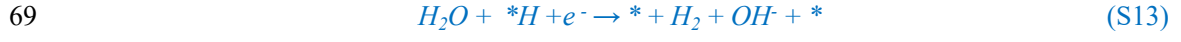


60 Meanwhile, the HER as the other reaction halfway could be summarized as two reaction
 61 mechanisms, including the Volmer–Heyrovsky and Volmer–Tafel reaction pathways, and both of
 62 them occur in two steps. Among Volmer–Heyrovsky reaction pathway, the H^+ adsorbed on the
 63 substrate, then the second H^+ from the solution reacts with first *H to form the H_2 molecule in the

64 Heyrovsky step under acid condition, and the corresponding reaction equations are as follows:



67 Under alkaline solution, the typical HER can be concluded by:



70 And the $*H$ is the adsorption intermediate. As for the Volmer–Tafel reaction pathways, two H+
71 adsorbed on the substrate's surface and form an H_2 molecule. Which can be described as follow:



73 For each of the elementary steps, the free energy difference under the effect of PH and an extra
74 potential bias can be written as:

$$75 \quad \Delta G_1 = G_{*OH} + 1/2 G_{H_2} - G^* - G_{H_2O} + \Delta G_U - \Delta G_{PH} \quad (S15)$$

$$76 \quad \Delta G_2 = G_{*O} + 1/2 G_{H_2} - G_{*OH} + \Delta G_U - \Delta G_{PH} \quad (S16)$$

$$77 \quad \Delta G_3 = G_{*OOH} + 1/2 G_{H_2} - G_{*O} - G_{H_2O} + \Delta G_U - \Delta G_{PH} \quad (S17)$$

$$78 \quad \Delta G_4 = \Delta G^* + 1/2 G_{H_2} - G_{*O_2} - G_{*OOH} + \Delta G_U - \Delta G_{PH} \quad (S18)$$

$$79 \quad \Delta G_5 = G_{*H} - 1/2 G_{H_2} - G^* + \Delta G_U + \Delta G_{PH} \quad (S19)$$

$$80 \quad \Delta G_6 = \Delta G^* + 1/2 G_{H_2} - G_{*H} + \Delta G_U + \Delta G_{PH} \quad (S20)$$

81 Where $\Delta G_1, \Delta G_2, \Delta G_3,$ and ΔG_4 belong to the OER process and ΔG_5 and ΔG_6 are the HER process.

82 And $G_{*OH}, \Delta G_U, \Delta G_{PH}, G_{*O}, G_{*OOH}, G_{O_2}, G_{*H},$ and G_{H_2} are the adsorption free energy of OH, O,

83 OOH, O₂, H, and H₂. $\Delta G_U, \Delta G_{PH}$ is the extra potential bias, energy contribution to different PH

84 concentrations, in which $\Delta G_{PH} = K_B T \times \ln 10 \times pH, \Delta G_U = -eU$. The Gibbs free energy of O₂

85 (G_{O_2}) will be obtained by $G_{O_2} = G_{H_2O} - 2G_{H_2} + 4.92$ eV, because the DFT method fails to

86 accurately describe the high-spin ground state of the O₂ molecule.

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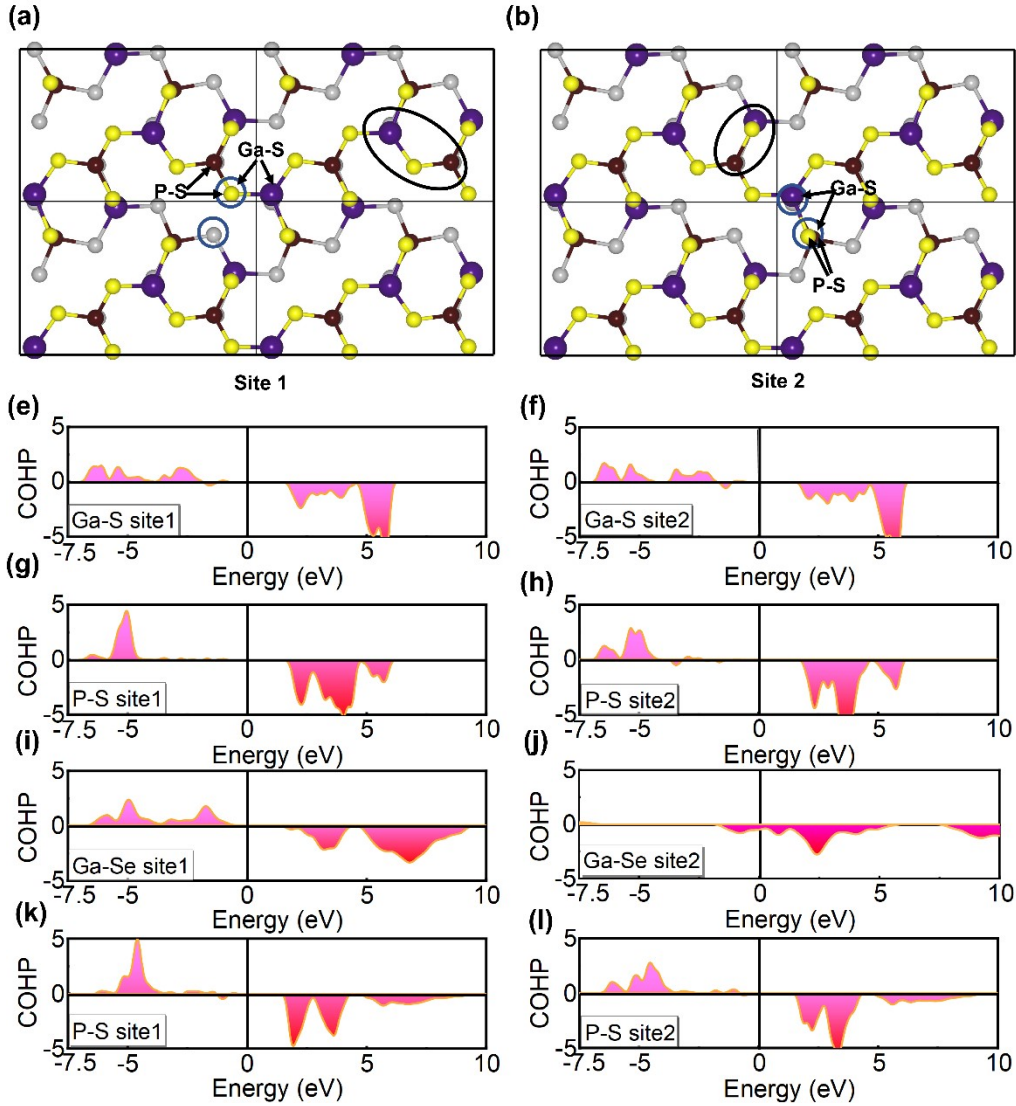
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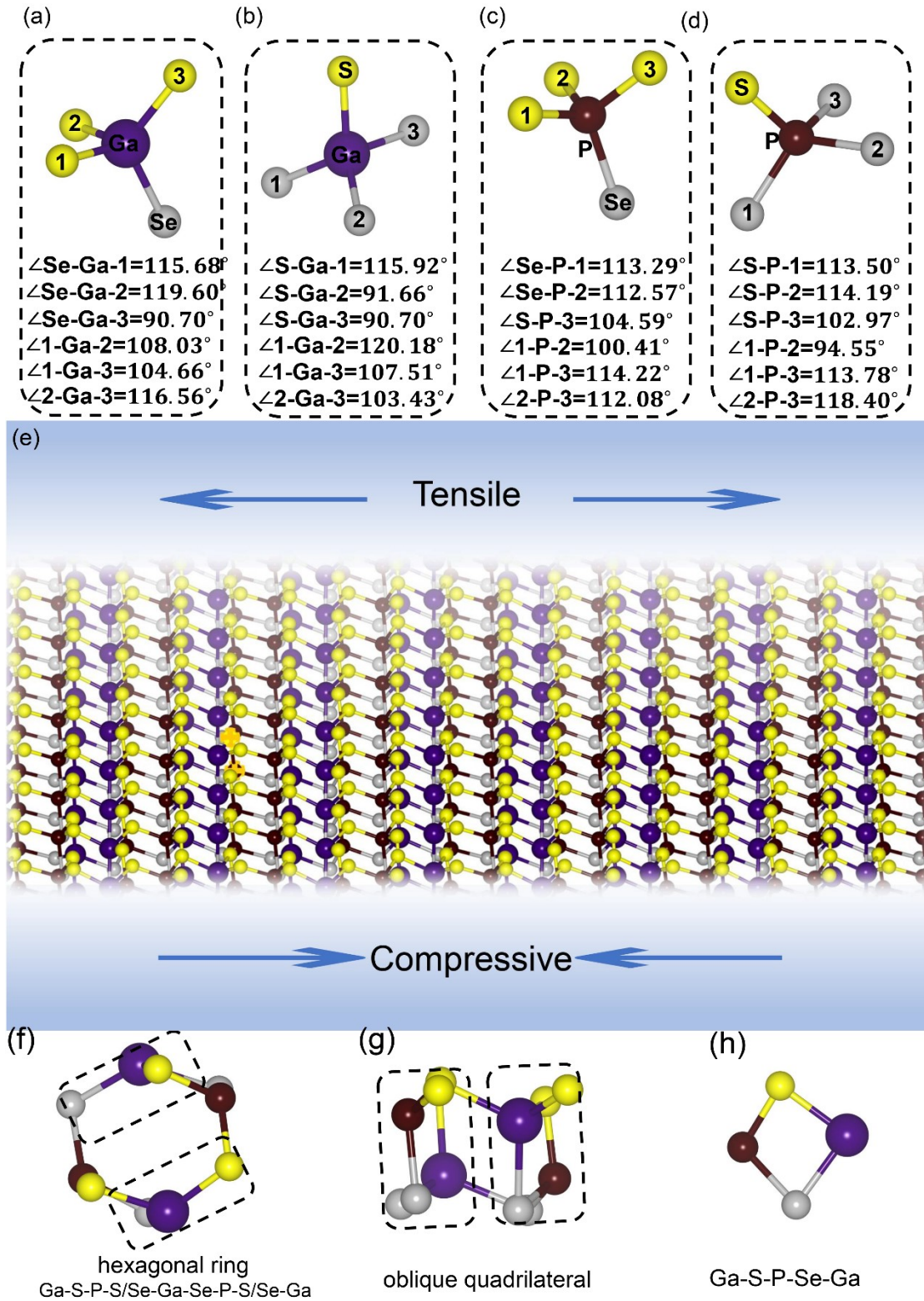
99 **Note 2:** As depicted in **Figure.S1**, two bonding sites, namely, site 1 and site 2 are chosen for judging
100 the bonding nature between Ga and Se, as well as P and Se atoms, respectively. For comparison,
101 the COHP for GaPS₄ is also considered. Generally, the negative value of COHP under the Fermi
102 level represents the antibonding state and vice versa. As shown in **Fig.S1**, for the same sites, two
103 antibonding states are observed in the Ga-S bond in the GaPS₄ system. However, none of the
104 antibonding states formed in the GaPS₂Se₂ system for Ga-Se bonds, indicating that the Ga-Se shows
105 stronger covalent bonds than Ga-S in the GaPS₄ system. However, all the bonding states of P-S/Se
106 show antibonding states in both GaPS₄ and GaPS₂Se₂ systems, demonstrating the weak covalent
107 bonding of P-S/Se.

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109

110 Figure S1: For the GaPS_4 and GaPS_2Se_2 system, each S/Se atom bonds with one Ga atom and one
 111 P atom (forming Ga-S-P and Ga-Se-P), respectively. As it can be seen from the geometry, the
 112 bonding nature between Ga-S-P and Ga-Se-P can be classified into two categories. The one is Ga-
 113 S-P or Ga-Se-P which is labeled by a black oval in the left figure (the two can be regarded as one
 114 site since they own similar bonding structures and they can superposition by rotating certain
 115 angles), we defined it as Site 1 (a). Similarly, the other one is also marked by a black oval (right
 116 figure), which is defined as Site 2 (b). (e)-(l) is the COHP between them, and the Fermi level is -
 117 3.44 eV in our calculation, which align at 0 eV for all of them.



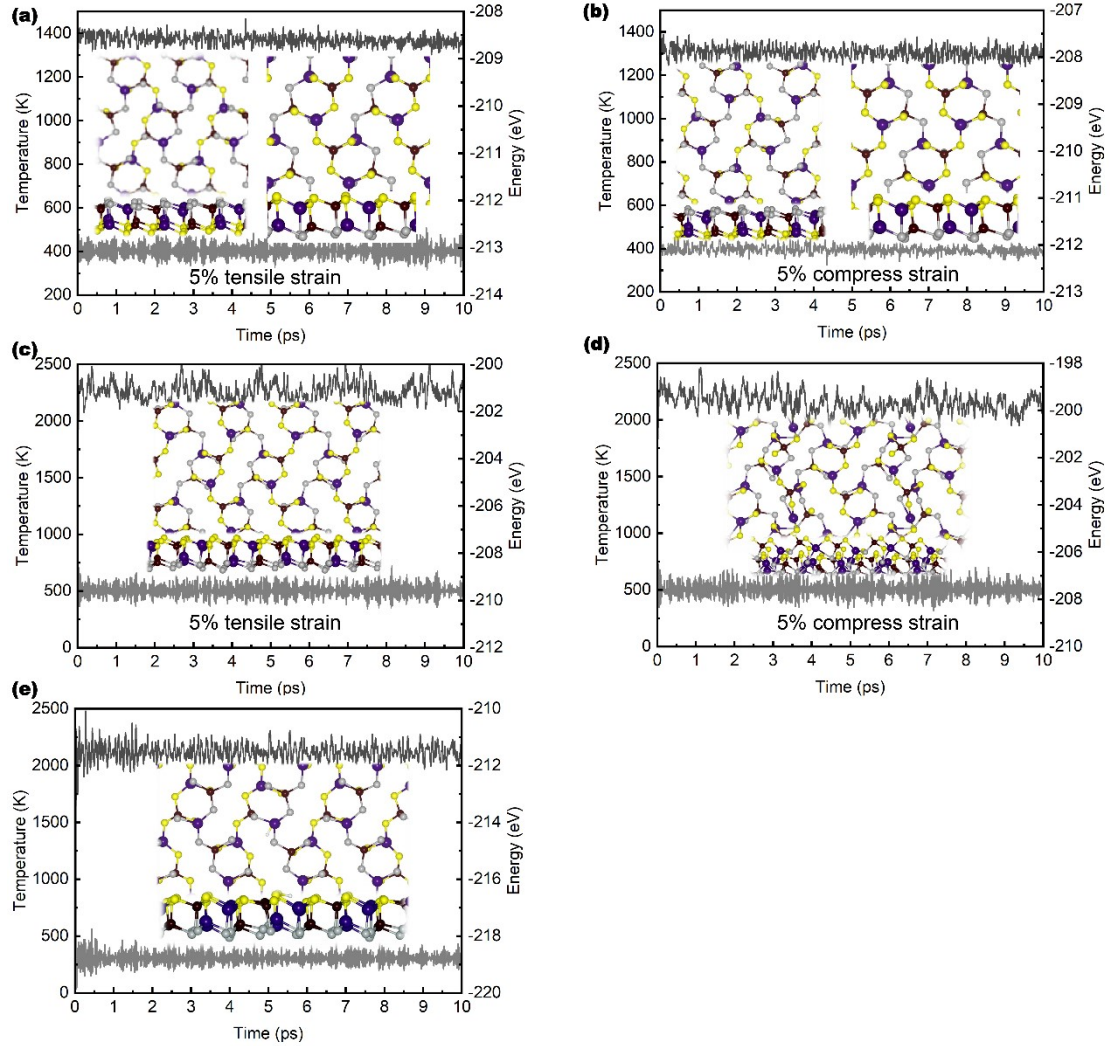
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119 Figure S2: Atomic structure of GaS_3Se (a), GaSSe_3 (b), PS_3Se (c), PSSe_3 (d). The S and Se elements

120 are marked with numbers, and the angles between three atoms are listed as well. (e) The hexagonal

121 ring in the primitive-cell (e), and each of the hexagonal contains two oblique quadrilateral (f), and

122 the structure of oblique quadrilateral (g). (h), (i) The tensile/compression strain applied from the a
 123 and b direction of the GaPS₂Se₂ monolayer. and the consistency of strained.
 124



125

126 Figure S3: (a), (b) the AIMD for the applied biaxial strain ($\pm 5\%$) at 400K lasting for 10 ps for the
 127 $1 \times 2 \times 1$ supercell of GaPS₂Se₂ monolayer, the inset pictures are the top and side structure of
 128 GaPS₂Se₂ after AIMD simulation and optimizing for the simulated structures (c), (d) the AIMD for
 129 the applied biaxial strain ($\pm 5\%$) at 500K lasting for 10 ps for the $1 \times 2 \times 1$ supercell of GaPS₂Se₂
 130 monolayer. (e) the AIMD simulation at 300K (To modulate the solvent medium, the temperature is
 131 set to 300K.) lasted for 10 ps for a $1 \times 2 \times 1$ supercell.

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135 **Note 3:** Calculation of the anisotropic Young's Modulus, Shear Modulus, and Poisson's Rate.

136 The **Hook's law** under the in-plane stress condition was implemented in this paper to explore the
 137 anisotropic properties of 2D GaPS₂Se₂, in which the correlation of stress (σ), elastic constant tensile
 138 (C_{ij}), and strain ε were corrected and expressed as[2]:

$$139 \quad \sigma_{xx} = C_{11}\varepsilon_{xx} + C_{12}\varepsilon_{yy} \quad (S21)$$

$$140 \quad \sigma_{yy} = C_{12}\varepsilon_{xx} + C_{22}\varepsilon_{yy} \quad (S22)$$

$$141 \quad \varepsilon_{zz} = 2C_{66}\varepsilon_{zz} \quad (S23)$$

142 where the standard Voigt notation was implemented to simplify the tensile notation. And the elastic
 143 constant can be obtained by the following equation[3]:

$$144 \quad E_S = 1/2C_{11}\varepsilon_{xx}^2 + 1/2C_{22}\varepsilon_{yy}^2 + C_{12}\varepsilon_{xx}\varepsilon_{yy} + 2C_{66}\varepsilon_{zz}^2 \quad (S24)$$

145 Here, E_S is the strain energy, and the tensile strain can be defined as $\varepsilon = (L_i - L_{i0})/L$ ($I = x, y$), in
 146 which the L_i and L_{i0} is the strained and unstrained lattice constant along the x and y -direction with a
 147 variety from -2% to 2% and a 0.5% increment. Based on this, the orientation-dependent Young's
 148 Modulus $E(\theta)$, Shear Modulus $G(\theta)$, and Poisson's Rate $\nu(\theta)$ can be calculated as[4, 5]:

$$149 \quad E^{-1} = S_{11}\cos^4\theta + S_{22}\sin^4\theta + 2S_{16}\cos^3\theta\sin\theta + 2S_{26}\sin^3\theta\cos\theta + (2S_{12} + S_{66})\cos^2\theta\sin^2\theta \quad (S18)$$

$$150 \quad -\nu(\theta)/E(\theta) = A + B\cos(4\theta + \psi_1) \quad (S25)$$

151 in which

$$152 \quad A = [(S_{11} + S_{22} - S_{66})/2 + 3S_{13}]/4 \quad (S26)$$

$$153 \quad B = \frac{\sqrt{(S_{26} + S_{16})^2 + [S_{12} - (S_{11} + S_{22} - S_{66})/2]^2}}{4} \quad (S27)$$

$$154 \quad \tan \psi_1 = \frac{S_{26} - S_{16}}{S_{12} - (S_{11} + S_{22} - S_{66})/2} \quad (S28)$$

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$$156 \quad 1/4G(\theta) = C + D\cos(4\theta + \psi_2) \quad (S29)$$

157 Here, C , D , and ψ_1 can be obtained by:

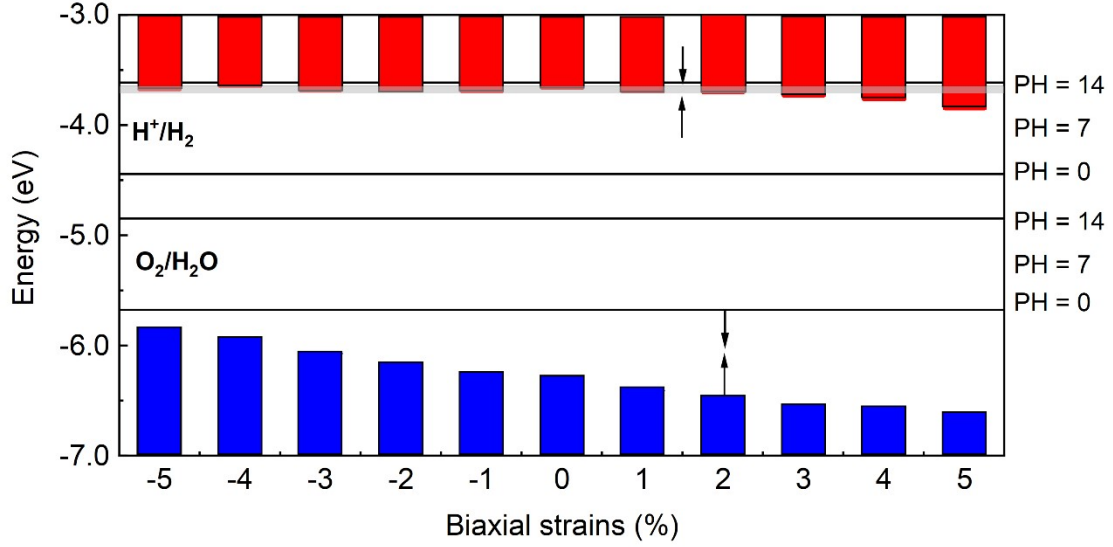
$$158 \quad C = (S_{11} + S_{22} - S_{12} + S_{66})/8 \quad (S30)$$

$$159 \quad D = \frac{\sqrt{(S_{66} + 2S_{12} - S_{11} - S_{22})^2/4 + (S_{26} - S_{16})^2}}{4} \quad (S31)$$

$$160 \quad \tan \psi_2 = \frac{2(S_{16} - S_{26})}{(S_{66} + 2S_{12} - S_{11} - S_{22})} \quad (S32)$$

161 Where θ belongs to $[0 - 2\pi]$, and $S_{ij} = C_{ij}$.

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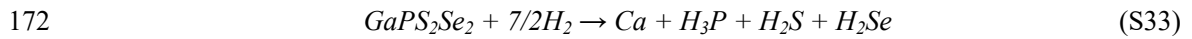
164 Figure S4: Strain tunable band edge positions for GaPS₂Se₂ monolayer under HSE functional

165 (does not consider the external electric field).

166

167 **Note 4:** Thermodynamic Oxidation and Reduction Potentials of GaPS₂Se₂ Monolayer in Aqueous
168 Solution

169 To shed light on the thermodynamic stability of the GaPS₂Se₂ monolayer in an aqueous
170 solution, the theory developed by Chen[6] was employed in this paper. The reduction of GaPS₂Se₂
171 monolayer by the photo-generated electron can be described by the following formula:



173 Where the Gibbs free energy difference of the productions and the reactants are the thermodynamic
174 reduction potential of the GaPS₂Se₂ monolayer (φ^{re}), which can be calculated by:

$$175 \quad \varphi^{re} = -[\Delta_f G^0(\text{Ga}) + \Delta_f G^0(\text{H}_3\text{P}) + \Delta_f G^0(\text{H}_2\text{S}) + \Delta_f G^0(\text{H}_2\text{Se}) - \Delta_f G^0(\text{GaPS}_2\text{Se}_2) - 7/2\Delta_f G^0(\text{H}_2)]/7eF +$$

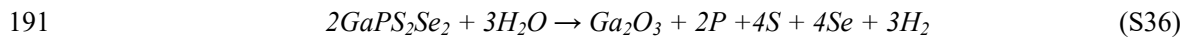
$$176 \quad \phi(\text{H}^+/\text{H}_2) \quad (\text{S34})$$

177 in which $\Delta_f G^0(\text{Ga})$, $\Delta_f G^0(\text{H}_3\text{P})$, $\Delta_f G^0(\text{H}_2\text{S})$, $\Delta_f G^0(\text{H}_2\text{Se})$, $\Delta_f G^0(\text{GaPS}_2\text{Se}_2)$, $\Delta_f G^0(\text{H}_2)$ are the Gibbs free
178 energy formation of Ga, H₃P, H₂S, H₂Se, and GaPS₂Se₂, H₂, respectively, e is the electronic charge,
179 F is the Faradic constant. Among them, the $\Delta_f G^0(\text{Ga})$, $\Delta_f G^0(\text{H}_3\text{P})$, $\Delta_f G^0(\text{H}_2\text{S})$, $\Delta_f G^0(\text{H}_2\text{Se})$ could be
180 found in the CRC Handbook of Chemistry and Physics[7], which was concluded in table S1.
181 Meantime, the Gibbs free energy formation of the GaPS₂Se₂ ($\Delta_f G^0(\text{GaPS}_2\text{Se}_2)$) is approximated to
182 the formation energy of GaPS₂Se₂, which was defined by:

$$E_{form} = E_{GaPS_2Se_2} - 4E_{Ga} - 4E_P - 8E_S - 8E_{Se} \quad (S35)$$

184 here, $E_{GaPS_2Se_2}$ could be obtained by DFT calculation, and E_{Ga} , E_P , E_S , E_{Se} is the chemical potential
 185 under the most stable state, which is -3.03 eV, -5.41 eV, -4.14 eV, and -3.50 eV, respectively.
 186 According to our DFT result, the energy value of the $GaPS_2Se_2$ unit is -105.06 eV, thus the formation
 187 energy of $GaPS_2Se_2$ is -0.43 eV per atom eventually according to the above equation. Finally, the
 188 ϕ^{re} was calculated as -0.04 V (vs CHE).

189 The $GaPS_2Se_2$ monolayer could be oxidized by the photogenerated holes according to the
 190 following equation.



192 similarly, the thermodynamic oxidation potential of the $GaPS_2Se_2$ monolayer (ϕ^{ox}), which could be
 193 defined as follows:

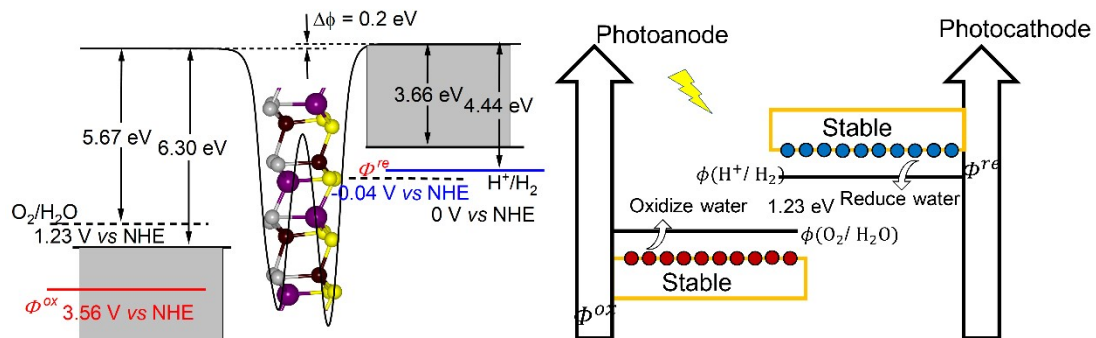
$$\phi^{ox} = [\Delta_f G^0(P) + \Delta_f G^0(Se) + \Delta_f G^0(S) + \Delta_f G^0(Ga_2O_3) - \Delta_f G^0(GaPS_2Se_2) - 3\Delta_f G^0(H_2O)]/6eF + \phi(H^+/H_2) \quad (S37)$$

196 in which $\Delta_f G^0(P)$, $\Delta_f G^0(Se)$, $\Delta_f G^0(S)$, $\Delta_f G^0(Ga_2O_3)$ are the standard Gibbs free energy of formation
 197 of P, Se, S, and Ga_2O_3 , which is also found in the CRC Handbook of Chemistry and Physics. By
 198 implementing the equations above, the calculated value of ϕ^{ox} is 3.56 V (vs NHE), which was plotted
 199 in Figure 8.

200 Table S1, the Gibbs free energy of each species used in this paper

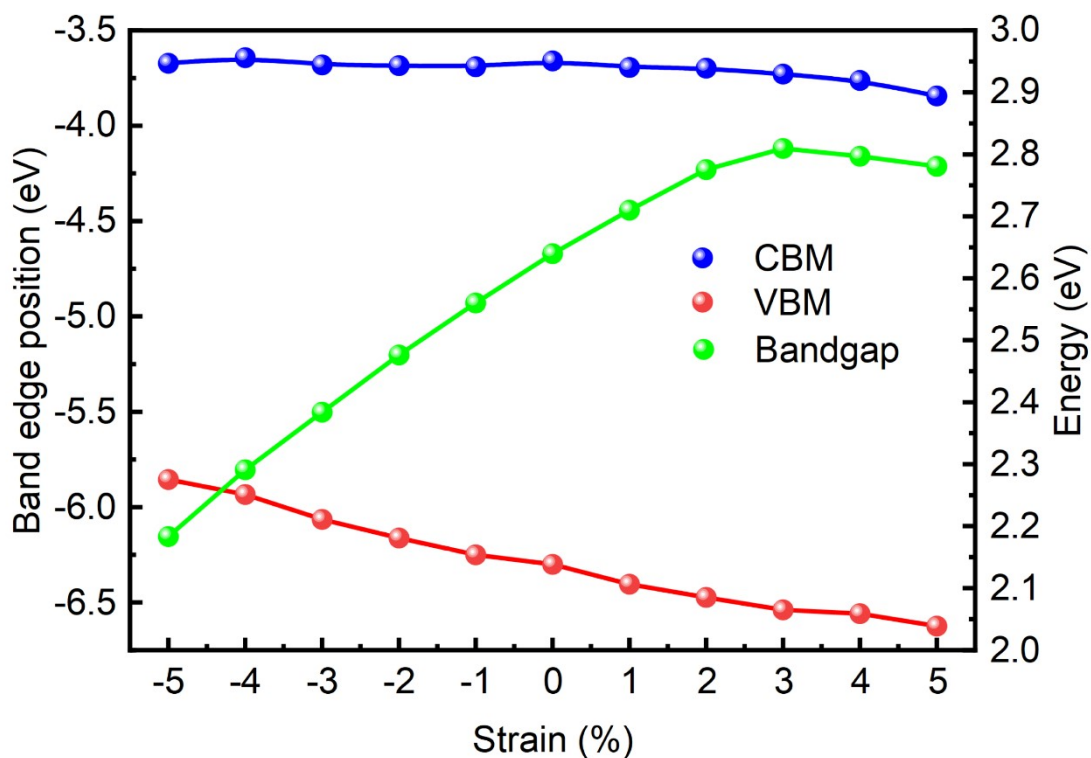
Molecular Formula	$\Delta_f G^0$	Molecular Formula	$\Delta_f G^0$
Ga	233.7	H₂S	-33.4
P	280.1	H₃P	13.5
S	187.0	H₂Se	15.9
Se	236.7	Ga₂O₃	-998.3
H₂O	-237.1	H₂	0

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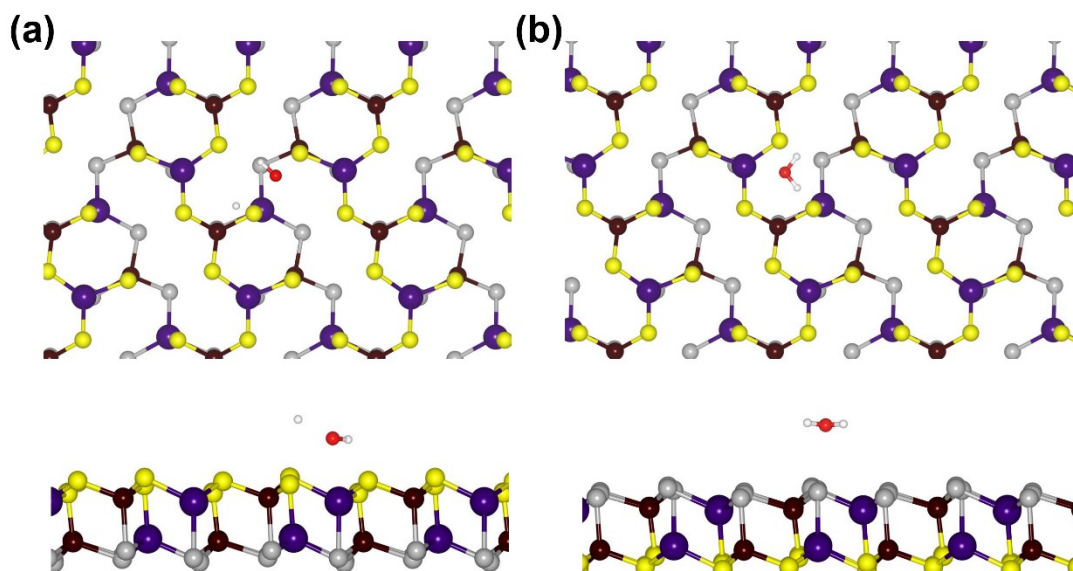
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203 Figure S5 redox potential of GaPS₂Se₂ and position of CBM and VBM after aligning with the
 204 reduction/oxidation potential of water.



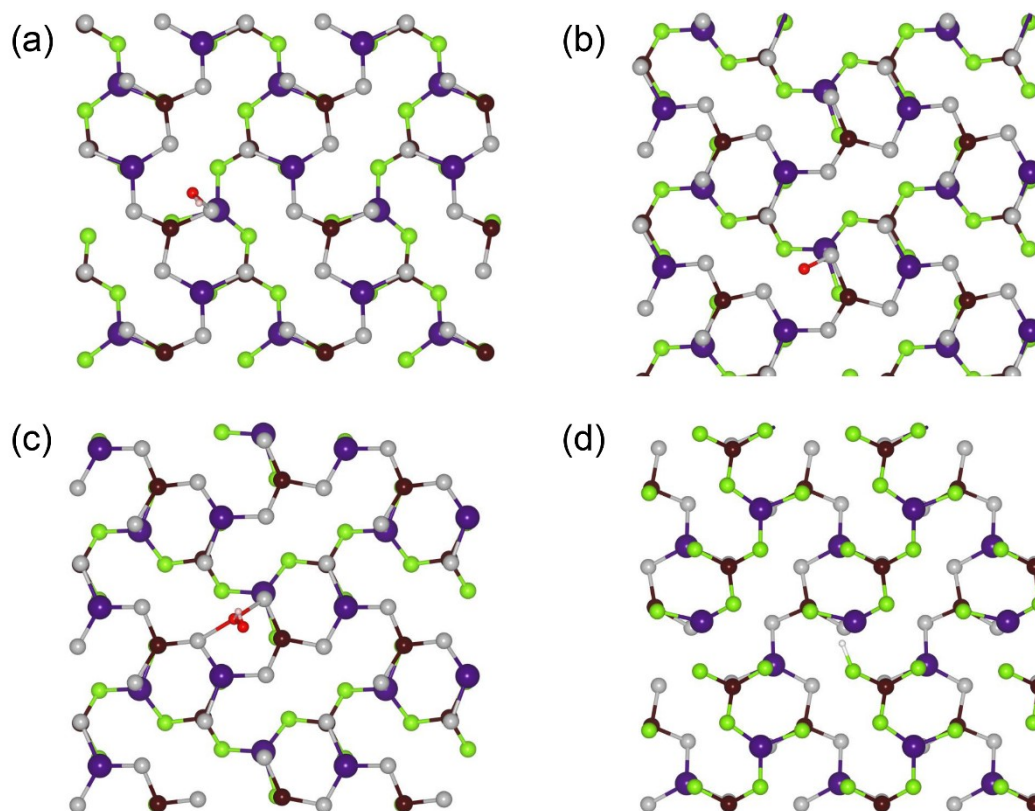
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206 Figure S6: Variations of CBM, VBM, and bandgap of GaPS₂Se₂ monolayers with biaxial
 207 and uniaxial lattice strains from -5% (compression) to 5% (tension).



208

209 Figure S7: Top and side views of the adsorption structures of H₂O molecule on the S (a) and Se (b)
 210 sides.



211

212 Figure S8: Structures of the adsorbed species (OH, O, OOH, H) of the applied 2% tensile strain
 213 system.

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